1	**Introduction**	**1**
2	**State of the Art**	**5**
2.1	Process Fundamentals	5
2.1.1	Laser-induced Metal Melt Pools	5
2.1.2	Melting Track Formation and Stability in Metal AM	18
2.2	Laser-based Metal AM Systems (powder bed)	24
2.2.1	Beam Sources and Optical Systems	25
2.2.2	Shielding Gas Flow	29
2.2.3	Novel Approaches for Metal AM	30
2.3	Interim Conclusion	32
3	**3DLP Process Principle**	**33**
3.1	Energy Input into Powder Bed	33
3.2	Exposure Sequence and Process Parameters	35
4	**Laboratory Machine Development**	**39**
4.1	Requirements Profile	40
4.2	Mechanical Subsystem	41
4.2.1	Working Head Positioning System	41
4.2.2	Build Platform and Powder Reservoir	42
4.2.3	Powder Application Unit	42
4.3	Beam Sources and Optical Unit	43
4.4	Software and Control	44
4.5	Shielding Gas System (SGS) and Shielding Gas Nozzle	46
4.5.1	Global SGS: General Layout	46
4.5.2	Local SGS: Nozzle Design	48
4.5.3	Spatter Deflection and Processing Atmosphere	49
4.6	3DLP Laboratory Machine	51
4.7	Machine Characterization	52
4.7.1	Time Response of Beam Sources	52
4.7.2	Thermal Shift, Spot Size and Intensity Distribution	57
4.7.3	Dynamics of Positioning System	59
4.8	Applied Material	59
4.9	Interim Conclusion	62
5	**Theoretical Modelling**	**63**
5.1	Energy Input within Melting Track	63
5.2	Energy Input on Leading and Exit Edges	64

5.3 Simulation of Temperature Fields 66
5.4 Calculation of Processing Times 67
5.4.1 Conventional L-PBF Exposure Sequence 69
5.4.2 3DLP Exposure Sequence 71

6 Process Development 73
6.1 Experimental Approach 73
6.2 Single Spot Melting Tracks 80
6.3 Multi-spot Melting Tracks 82
6.3.1 Influence of Spot Distance Δy_S 82
6.3.2 Influence of Spot Number n_S and Exposure Speed v_B 84
6.3.3 Influence of Processing Atmosphere 88
6.3.4 Influence of Spot Arrangement 90
6.3.5 Influence of APD 98
6.3.6 Interim conclusion 101
6.4 Single Melting Layers 103
6.4.1 Influence of Line Distance Δy_L 103
6.4.2 Influence of Spot Arrangement 104
6.4.3 Influence of APD 109
6.4.4 Interim conclusion 112

7 Part Quality 113
7.1 Experimental Approach 113
7.2 Density 119
7.3 Surface Roughness 122
7.4 Dimensional Accuracy and Detail Resolution 130
7.5 Mechanical properties 136

8 Processing Time Evaluation 137
8.1 Approach 137
8.2 Process Comparison 138
8.2.1 Total Exposure Time 138
8.2.2 Exposure Time Composition Conventional Process 139
8.2.3 Exposure Time Composition 3DLP 141
8.2.4 Influence of Process Parameters 143

9 Summary and Outlook 147

10 Bibliography 151

11 Abbreviations and symbols 159

12 Annex 167